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Packaging with double-side cooling capability for SiC devices, based on silver sintering

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Abstract—Although they can operate at high temperature, SiC devices require efficient thermal management. One solution is to use a dual-side cooling packaging, where heat can be extracted through two surfaces. Here, such a package is presented, using only materials which can operate at high temperature (>200°C): ceramic substrates, silver sintering, fluorinated parylene. Due to the small feature size of the SiC dies used, a special care is given on the etching resolution of the substrates. The complete manufacturing process is presented, and some characterization results are given to demonstrate that the package is operational.

I. INTRODUCTION

Silicon-Carbide (SiC) power semiconductor devices are especially suited to high temperature operation (>200 °C). In particular, Junction Field Effect Transistors (JFETs) can operate reliably at elevated temperature [1], [2], because they do not suffer from gate oxide issues. High-temperature capability is desirable for applications such as aerospace (especially near the jet engine or the brakes of an aircraft), oil and gas drilling, or automotive [3], where the devices may operate in harsh ambient conditions.

However, despite their inherent capability to operate at high temperature, which originates from the large energy band-gap of SiC [4], SiC JFETs are prone to thermal runaway [5] (this would also be true of other unipolar devices such as Schottky diodes [6] or MOSFETs); as their on-state resistance ($R_{DS_{on}}$) increases strongly with the temperature ($R_{DS_{on}} \propto T^{2.3}$ or more [7]), so do their losses. If insufficient cooling is provided to the JFET, this yields to a race condition in which increasing losses result in ever higher junction temperature. This is known as thermal runaway, and usually results in the destruction of the device.

As a consequence, these devices must be attached to an efficient thermal management system: thermal resistances of around 1 K/W are required [7], even though the temperature of the ambient air surrounding the converter can be as high as 200 °C or more.

One limitation of standard packaging solutions is that cooling is provided through one side of the dies only. Many research groups have proposed improved packaging structure [8], [9], and some of them provide double-side cooling [10]. In most cases, these power modules have the so-called “sandwich structure”, where the dies are placed between two ceramic substrates, which provide both thermal conduction and electrical insulation. This is the case of the modules presented in [11], [12], [13], [14]. In some other cases, a single ceramic substrate is used, and electrical isolation is provided through one side only [15], although heat can be extracted through both sides of the package.

An important issue in these packages is to provide some spacing between the topside of the power dies and the upper substrate: a direct contact with the flat metal layer of the substrates would cause a short circuit of the edge protection features on the dies. As a consequence, different solutions were proposed, for example using small cylinders to connect the dies and the upper substrate [11], [12], or a single, massive spacer [14]. Another solution, which is also used in this paper, is to form protruding features on the metal layer of the substrate [13].

Most of the structures proposed so far are based on solder interconnects. This is a very mature technology, but is not so well suited to high temperature operation [16]. Among the die attach solutions that can be used at high temperature [17], [18], silver sintering [20] is especially attractive. This solid-state process can be performed at a temperature of 240 °C, but the resulting die attach (pure silver), can operate reliably at higher temperature (for example 300 °C in [19]).

Most of the research on silver sintering focuses on backside die attach, but some papers investigate topside contact: in [21], a ribbon is attached using silver sintering, as a replacement for aluminium wire-bonds; in [22], dies are attached on both sides using silver sintering, with the topside interconnect provided by a flex circuit. In [23], a sandwich structure is assembled using (gold) sintering, but no details are given regarding the high voltage capability of the package: apparently, flat ceramic substrates are used, without any spacer. As a consequence, the topside of the dies is very close to the metal layer of the substrate. Finally, a sandwich structure is assembled using silver sintering in [24], and shows good voltage blocking capability (switching tests performed at 750 V). Unfortunately, the topside interconnection of the dies is not detailed.

As described above, some spacing is required between the edge protection of the dies and the surrounding metal layer, so
that the blocking voltage capability of the dies is maintained once packaged. For the same purpose, a suitable encapsulation of the dies is also required [25], as the voltage breakdown of air is not sufficient. Classically, Silicone gels and epoxy resins are used for this purpose. Both have been successfully used in sandwich packages ([13], [14] respectively). Most of these materials are not suited to high temperature operation, though, as they degrade rapidly (a few days at 250 °C, [26]). Other materials can operate at a higher temperature, or for a longer time: polyimides [26], [27], and parylene HT [27], [28]. This is the later solution that was selected for the module presented here, and it is described in the article. Indeed, silver migration [29], one of the issues associated with high temperature operation of silver sintered joints, was found to be clearly reduced using parylene encapsulation [28], [30].

In the next section, we present the concept of the sandwich package. Section III describes the manufacturing process. Evaluation results are presented and discussed in section IV.

II. DESIGN OF THE POWER MODULE

A 3-D view of the power module is visible in figure 1. It comprises two SiC JFETs (SiCED, now Infineon) and two ceramic tiles. Two variants of the SiC JFET were used, and their layouts are presented in figure 2: the $4 \times 4 \text{ mm}^2$ version has a 60mΩ on-state resistance, while that of the smaller (and older) $2.4 \times 2.4 \text{ mm}^2$ version is 500 mΩ. Both dies are rated at 1200 V, and were successfully tested at temperatures exceeding 300 °C. From a packaging point-of-view, these devices have the source and gate pads on the topside of the die, and the drain on the bottom-side. The gate pad is fairly small (0.35 by 0.56 mm or 0.41 by 0.86 mm).

A close-up view of the interconnects to be realized is visible in Fig. 3. It shows that in order to provide both gate and source contacts without creating any short circuit between these pads, and to avoid touching the edge protections of the die, a two-level copper layer is necessary: protruding features form the actual contact with the die, while the thinner areas are used to route the electrical circuit. The small sizes of the die and of its gate pad require a “high resolution” etching of the copper (0.2 mm spacing for 0.3 mm-thick copper conductors). The etching technique, which is not compatible with the guidelines of the industry [31], is described in section III. For high-temperature operation, an attractive ceramic material is Silicon Nitride ($\text{Si}_3\text{N}_4$) [25], [18]: it offers good insulating properties, even at elevated temperatures, and better mechanical strength than the other ceramic materials (alumina and aluminium nitride). This latter point is important to survive the large temperature swing associated with high temperature applications. However, due to cost considerations, alumina Direct Bonded Copper (DBC) substrates were used during the work presented in this article.

The module forms a half-bridge circuit, as depicted in Fig. 4a. An arbitrary design choice is to give both JFETs the same orientation (i.e. to have their gate and source pads contacting the same DBC tile of the sandwich structure, Fig. 4b). This makes it necessary to provide a direct contact between both tiles. The advantages of this organization is to have all the control connections on one tile, and the two power DC connections on the other. Another possibility would have been to place the JFETs in opposite orientation (Fig 4c).

As presented in section I, silver sintering is an attractive alternative to solders, especially in the case of high temperature applications. In this paper, silver sintering is used to assemble the package, and to provide both topside and bot-
A dry-film photoresist (Dupont, Riston PM275) layer is laminated (Bernier Electronik, M300) on top of the substrate to provide additional protection of the protruding features (see below).

(b) The dry film photoresist is exposed for 8 s through a second mask, with the parameters described in step (c).

(c) The photosensitive layers are stripped and the substrate is cleaned; then a second coat of photosensitive resin is applied, using the same parameters as in step (b).

(d) The exposed copper layer is etched half-way using ferric Chloride in a spray etcher (Bernier Electronic PR2030S). This step takes approximately 10 min, depending on the ferric chloride condition.

(e) The remaining resin is stripped and the substrate is cleaned, then a second coat of photosensitive resin is applied, using the same parameters as in step (b).

(f) The resin is patterned using a second mask, with the parameters described in step (c).

(g) A dry-film photoresist (Dupont, Riston PM275) layer is laminated (Bernier Electronik, M300) on top of the substrate to provide additional protection of the protruding features (see below).

(h) The dry film photoresist is exposed for 8 s through a third mask (the negative of the second mask, as the resin is positive and the dry-film negative), and developed in 1 % Na$_2$CO$_3$ solution.

(i) Finally, the exposed copper is etched away (≈ 10 min. in ferric chloride), the photosensitive layers are stripped (acetone) and the substrate is cleaned and singulated (Disco DAD3220)

At steps (a), (e) and (i), the following cleaning procedure is used (2 min per bath): if a photosist coat is present, strip it in a first acetone bath; then 2 min in clean acetone; ethanol; de-oxidation in hydrochloric acid (37 %); rinsing in deionized water; ethanol; drying using a nitrogen blow nozzle. This was found to remove most traces (including residues from the copper etching steps), and to leave a surface that wouldn’t re-oxidize easily. A clean surface is especially important for the dip-coating steps, as it helps achieving a uniform coat.

Two layers of photoresist materials are coated for the second copper etching step (steps (e) and (g)). This was found to be necessary because of the surface tension of the dip-coated resin (see Fig. 6): although it follows well the steep copper profile, the resin coat tends to be much thinner around the edges of the protruding features, so it doesn’t provide enough protection against the ferric chloride copper etchant. The dry-film photoresist is much thicker (75 µm), but it is too rigid to conform to the copper surface (Fig. 5(g)), so it cannot protect the lower copper surface properly (“tenting” effect). As a consequence, we decided to use both processes simultaneously: the liquid resin provides a high resolution, conformal coating, while the dry-film acts as an “umbrella” over the protruding features. This makes the overall process more complex, but was found to be necessary to achieve the high resolution described in section II.
Due to surface tension, the resin coat is thinner on the edges of the feature and appears lighter (left picture), although the flat areas and the "cliffs" of the feature are well protected. A dry film photoresist is laminated on top (right picture) to provide additional protection.

(a) Silver paste is stencil-printed on one of the DBC substrates (using binoculars for proper stencil/substrate alignment). A 50 µm-thick, laser cut, stainless steel stencil (DB Products) is used. The paste deposit is then dried for 5 min on a hotplate at 85 °C (Fig. 10).

(b) The substrate is placed in a ceramic jig.

(c) A second jig, with cutouts for the dies, is positioned. Two SiC dies are placed in the openings, gate and source facing downwards. A die Bonder (JFP PP One) is used at this stage to control the placement force (50 mN).

(d) This stack is placed between the platens of a custom heating press [34]. The sintering profile is as follows: a 30 min step at 85 °C, for drying, then a fast ramp (70 °C/min) to 240 °C. This temperature is maintained for 30 min for the actual sintering to take place, under a pressure of 2 MPa, and the assembly is left to cool down to room temperature.

(e) The small jig is removed before the second assembling step. At this stage, the gate and source of both dies are bonded to a DBC substrate. As this is the most critical stage of the process, a simple electrical test can be performed to ensure there are no short circuit or unconnected pads: a hand multimeter is used to check that gate and source have a capacitive behaviour (∼1-4 nF, depending of the die size)

(f) The second DBC substrate is stencil-printed and dried for 5 min at 85 °C. On both substrate, some more fresh paste is applied manually (with the tip of sharp tweezers) on the pad which contacts with the spacer, to ensure good contact (the spacer is only 350 µm-thick, while the dies are 380 µm-thick).

(g) The first DBC, the copper spacer and the second DBC are mounted in the alignment jig.

(h) The stack undergoes a second sintering step, with the same parameters as in step (d).

(i) The assembly is formed.

This process is made possible thanks to silver sintering: once sintered (at 240 °C), the paste forms a solid silver joint (which melts at 961 °C); therefore, it is possible to perform a second sintering step (Fig. 8(h)) without altering the result of the first (Fig. 8(d)). With soldering, this would have required two distinct soldering alloys to ensure different melting points ("staged assembly", [24]).

Another special feature of the silver paste is the lack of liquid phase, as silver sintering is a solid-state phenomenon. This means that the displacement of bonding material only
occurs at the microscopic scale, during the densification of the silver powder into a solid. There is no macroscopic movement, as can be observed with solders due to the wetting phenomenon. The advantage is that this ensures the dies do not move during sintering (this could happen with soldering), so alignment is preserved. The downside is that there is no “tolerance” in the process: any misalignment, bridge, or bad contact between the die and the silver paste is preserved too. With solder, small issues tend to be self-corrected. A solution is to take advantage of the viscous phase of the paste to provide some compliance during the positioning of the dies.

An example is visible in Fig. 11: here, a glass fragment is used in place of the die, to observe the spreading of the silver paste during the placement operation. If the die is placed directly on the fresh paste deposit, even a small force (50 mN) is enough to obtain a large spreading. If the paste is slightly dried (5 min at 85 °C for example), there is virtually no spreading but the paste retains some tackiness. The tackiness is required to prevent the die from moving when handling the assembly in the lab (to go from the die bonder to the sintering press).

Finally, after assembly, the module is encapsulated. Here, we use a layer of fluorinated parylene. This material was found to have an excellent long-term reliability at high temperature (more than 1000 h at 300 °C in [25], [28]). It has excellent dielectric properties (several MV/cm [25]). Furthermore, the chemical vapor phase deposition mechanism of this material ensures a conformal coating, with uniform deposition of a film of parylene, even on the most intricate geometries. This is well suited to the package described here, as small cavities (around the gate contact, for example) can be difficult to coat.

A photograph of the fully assembled package is given in Fig. 12.
### IV. Analysis of the Package

Results of a room-temperature static characterization of the power module are presented in Figs. 13 and 14. The direct characteristic is acquired using a Tektronix 371A curve tracer, using spring probes to contact with the power module (hence the limited measurement range for the current). The results show that the JFETs operate properly, with a -25 V threshold voltage (these devices are normally-on, i.e. are in the on-state in the absence of gate voltage).

In the blocked state, Fig. 14 shows that the leakage current remains low (<10 nA) up to 600 V. Then, there is a gradual increase which is related to the JFET itself. At 1020 V, there is a dramatic increase in the leakage current which can be attributed to the breakdown of the encapsulation layer. Although breakdown occurred at a lower voltage than the rated voltage of the JFET (1200 V), it is must be noted that for this sample, only 2 µm of parylene-D were used, for practical reasons. A thicker parylene layer (20 µm, as initially planned) should be sufficient to sustain 1200 V.

### V. Conclusion

This article detailed a “sandwich” packaging structure suited to the operation of SiC devices. It only uses materials suited to high-temperature (> 300 °C). In particular, the assembly is performed using silver sintering for both sides of the dies.

A special care was given to the patterning of the DBC substrates, to form protruding features which mate with the SiC dies without interfering with their peripheral protection. The proposed copper etching technique has a sufficient resolution to allow the formation of small features (smaller than 0.4 × 0.6 mm², with a spacing of 0.2 mm).

Future development will aim at reinforcing the mechanical strength of the package: at the moment, both substrates are assembled through the SiC dies (and the spacer). As a consequence, any external mechanical stress is transmitted to the dies, which makes the power module fragile. This could be prevented either by using a solid epoxy encapsulation (providing it is compatible with the operating temperature), such as in [14], or by forming separate protrusions on the DBC substrates to put them in direct contact (such as in [13]). The effect of the possible double-side cooling on the thermal resistance of the package should also be assessed.

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